

### **EXAMINER'S AMENDMENT**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Michael Lee on October 22, 2009.

The application has been amended as follows:

In claim 1, line 11, after "polysilicon layer;" insert - - directly thereafter - -

Cancel claim 15.

In claim 16, line 7, "polysilicon layer; and" insert - - directly thereafter - -

It was also agreed upon to change the order of the claims so that claims 16, 18-19 will become claims 1-3 in the issued patent.

Applicant's arguments, see page 6, last two paragraphs, and page 8, last paragraph, filed 6/29/09, with respect to Chen and Brown have been fully considered and are persuasive.

Additionally, Brown has three different etch steps with three separate etch gas compositions in the etching of polysilicon with doped and undoped regions, not only two etch steps with the cited gases, as in the instant invention. The claims have been amended to cite "directly thereafter" so

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that the claims cite two etches for the polysilicon layer. The rejections over Chen and Brown have been withdrawn.

### ***Conclusion***

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. The cited art shows methods of etching doped and undoped regions.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Anita K. Alanko whose telephone number is 571-272-1458. The examiner can normally be reached on Mon-Fri until 3:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 571-272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Anita K Alanko/  
Primary Examiner, Art Unit 1792